



IFW

Docket No.: P8375.0002
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Hidemitsu Aoki et al.

Patent No.: 6,890,391

10 680 216

Confirmation No.: 7422

Issued: May 10, 2005

Art Unit: 1746

For: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE AND
APPARATUS FOR CLEANING
SUBSTRATE

Examiner: B. S. Carrillo

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT (IDS)
AFTER ISSUANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the cited reference be inserted into the file of the above-captioned patent. We acknowledge that the reference will not be considered, and that the reference will not be of record.

Dated: February 15, 2006

Respectfully submitted,

By

Michael J. Scheer

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PTO/SB/08a/b (07-05)

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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Patent Number	6,890,391
				Issue Date	May 10, 2005
				First Named Inventor	Hidemitsu Aoki
				Application No.	10/680,216
				Examiner Name	B. S. Carrillo
Sheet	1	of	1	Attorney Docket Number	P8375.0002

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	AA*	US-5,749,159	05-12-1998	Schwenkler	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				

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Examiner Signature		Date Considered	
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